

2812  
#3/105  
DKing  
11/1/01  
Docket: 740756-2351

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
Shunpei YAMAZAKI et al. )  
Based On Serial No. 09/932,935 ) Art Unit: 2812  
Which Was Filed: August 21, 2000 ) Examiner: V. Simkovic  
For: LASER APPARATUS, LASER )  
ANNEALING METHOD, AND )  
MANUFACTURING METHOD )  
OF A SEMICONDUCTOR DEVICE )

**INFORMATION DISCLOSURE STATEMENT**

Honorable Commissioner for Patents  
Washington, D.C. 20231

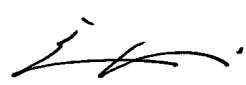
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99 it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

**CERTIFICATE OF MAILING**

Respectfully submitted,

  
Eric J. Robinson  
Registration No. 38,285

NIXON PEABODY LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
(703) 790-9110

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 9/24/01

